EAST Search History

EAST Search History (Prior Art)

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S493	3266	430/322.ccls.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2010/09/16 08:47
S494	315	S493 and (fluorinated)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2010/09/16 08:48
S498	748	S497 and (pattern\$4)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2010/09/16 08:49
S497	1305	430/273.1.ccls.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2010/09/16 08:49
S496	357	S495 and (immersion)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2010/09/16 08:49
S495	13135	jsr.as.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2010/09/16 08:49
S499	4	S495 and S498	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2010/09/16 08:50
S501	178	S500 and (upper adj layer)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2010/09/16 09:06

S500	3266	430/322.cdls.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2010/09/16 09:06
S502	4228	((upper adj layer) (protect\$3 adj film) (overcoat)(cover adj layer)(upper adj resist) (topcoat)(top adj coat) (top-coat)(protect\$3 adj layer)(protect\$3 - layer)(barrier adj layer) (anti-reflective) (antireflective) (permeable adj layer) (bilayer)) and ((immersion adj lithography)(immersion adj expos\$3))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2010/09/16 09:34
S503	1164	(fluor\$7) same ((upper adj layer)(protect\$3 adj film)(overcoat)(cover adj layer)(upper adj resist)(topcoat)(top adj coat)(top-coat)(protect \$3 adj layer)(protect\$3 -layer)(barrier adj layer) (anti-reflective) (antireflective) (permeable adj layer) (bilayer)) and ((immersion adj lithography)(immersion adj expos\$3))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2010/09/16 09:46
S504	1085	S503 and (pattern\$4)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2010/09/16 09:47
S505	112106	(solvent) same ((\$2propanol) (\$2butanol)(\$2methyl \$2propanol)(\$2methyl \$2pentanol)(\$2methyl \$2pentanol))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2010/09/16 09:53
S506	234	S504 and S505	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2010/09/16 09:54

,	,	; ;	,	, ,		
S507	1	11/857,645.app.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2010/09/16 10:21
L1	3	"20030232940"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2010/09/16 14:34
L2	2	"6803434".pn.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2010/09/16 14:37
L4	3	"20050202340"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2010/09/16 14:38
L3	2	"6943271".pn.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2010/09/16 14:38
L12	1085	L11 and L9	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2010/09/16 14:43
L11	1085	L10 and (pattern\$4)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2010/09/16 14:43
L10	1164	(fluor\$7) same ((upper adj layer)(protect\$3 adj film)(overcoat)(cover adj layer)(upper adj resist)(topcoat)(top adj coat)(top-coat)(protect \$3 adj layer)(protect\$3 -layer)(barrier adj layer) (anti-reflective) (antireflective) (permeable adj layer) (bilayer)) and ((immersion adj lithography)(immersion adj expos\$3))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2010/09/16 14:43

L9	#4228	((upper adj layer) (protect\$3 adj film) (overcoat)(cover adj layer)(upper adj resist) (topcoat)(top adj coat) (top-coat)(protect\$3 adj layer)(protect\$3 layer)(barrier adj layer) (anti-reflective) (antireflective) (permeable adj layer) (bilayer)) and ((immersion adj lithography)(immersion adj expos\$3))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2010/09/16 14:43
L13	303	430/270.1.ccls. and (fluor\$7) same ((upper adj layer)(protect\$3 adj film)(overcoat)(cover adj layer)(upper adj resist)(topcoat)(top adj coat)(top-coat)(protect \$3 adj layer)(protect\$3 -layer)(barrier adj layer) (anti-reflective) (antireflective) (permeable adj layer) (bilayer)) and ((immersion adj lithography)(immersion adj expos\$3))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2010/09/16 14:45
L14	32	maeda.in. and (fluor \$7) same ((upper adj layer)(protect\$3 adj film)(overcoat)(cover adj layer)(upper adj resist)(topcoat)(top adj coat)(top-coat)(protect \$3 adj layer)(protect\$3 -layer)(barrier adj layer) (anti-reflective) (antireflective) (permeable adj layer) (bilayer)) and ((immersion adj lithography)(immersion adj expos\$3))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2010/09/16 14:50
L15	3	"20050266354"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2010/09/16 15:14

L16	180	li.in. and (topcoat)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	2	2010/09/16 15:15
L17	39	li.in. and (topcoat) and (\$5resist\$1)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2010/09/16 15:54

EAST Search History (Interference)

<This search history is empty>

9/16/2010 4:49:35 PM

C:\ Documents and Settings\ cjohnson5\ My Documents\ EAST\ Workspaces\ 10586187.wsp